



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Shinichi NAGAHAMA et al.

Application No.: 10/614,342

Confirmation No.: 7861

Filed: July 8, 2003

Art Unit: 2815

For: NITRIDE SEMICONDUCTOR DEVICE  
COMPRISING BONDED SUBSTRATE AND  
FABRICATION METHOD OF THE SAME

Examiner: G. C. Eckert

**AMENDMENT UNDER 37 CFR 1.111**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Action of January 18, 2005, please amend this application as follows:

**Amendments to the specification begin on page 2 of this paper.**

**Amendments to claims begin on page 3 of this paper.**

**Remarks begin on page 12 of this paper.**